# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF EXPRESS MAILING Attorney Docket No.: LMRX-P029/P1180 nerely certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service First Named Inventor: CHENG on December 16, 2003, in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1,10, Mailing Label Number EL98844 778US addressed to May Stop Patent Application, UTILITY PATENT APPLICATION TRANSMITTAL (37 CFR. § 1.53(b)) Mail Stop Patent Application Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 Sir: This is a request for filing a patent application under 37 CFR. § 1.53(b) in the name of inventors: Yu CHENG, Helen ZHU, Pohray VINAY, Xiao HANZHONG, and Peter LOEWENHARDT METHODS AND APPARATUS FOR THE OPTIMIZATION OF PHOTO RESIST For: ETCHING IN A PLASMA PROCESSING SYSTEM **Application Elements:** 17 Pages of Specification, Claims and Abstract 7 Sheets of formal Drawings **Accompanying Application Parts:**

# Assignment and Assignment Recordation Cover Sheet (recording fee of \$40.00 enclosed) Combined Declaration and Power of Attorney 37 CFR 3.73(b) Statement by Assignee Information Disclosure Statement with Form PTO-1449 Copies of IDS Citations Preliminary Amendment Return Receipt Postcard Non-Publication Request under 35 USC 122(b)(2)(B)(i) Other:

## PLEASE DO NOT CHARGE FEES AT THIS TIME

Check No in the amount of \$is enclosed to cover the filing fees and Check No in the amount of \$is enclosed
The Commissioner is authorized to charge any fees beyond the amount enclosed which may be required, or to credit any overpayment, to Deposit Account No. 50-2284 (Order No).
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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: CHENG et al.

Attorney Docket No.: LMRX-P029/P1180

Application No.: Filed Herewith

Examiner: UNASSIGNED

Filed: Herewith

Group: UNKNOWN

Title: METHODS AND APPARATUS FOR THE OPTIMIZATION OF PHOTO RESIST ETCHING IN A PLASMA PROCESSING

**SYSTEM** 

CERTIFICATE OF EXPRESS MAILING

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on December 16, 2003, in an envelope as "Express Mail Post Office to Addressee" service und EL988441778US, addressed to Mail Stop Patent Application, Commissioner for Patents, P. O. Box

Sandra Halliwell

### NONPUBLICATION REQUEST UNDER 35/USC 122(b)(2)(B)(i)

Mail Stop Patent Application Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

I hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing.

I hereby request that the attached application not be published under 35 USC 122(b).

Respectfully submitted,

Alexander Sousa

Registration No. 50,671